



<u>Foreign Application</u>	<u>Issue Date</u>	<u>Country</u>
DE 100 52 170 C2	October 31, 2002	DE
DE 101 22 364 A1	November 21, 2002	DE
DE 100 12 610 A1	September 27, 2001	DE

**Articles**

- 1) Appels, J.A., H.M.J. Vaes, "High Voltage Thin Layer devices (Resurf Devices)", Philips Research Laboratories Eindhoven – Netherlands, IEEE, © 1979, pages 238 – 241, (4 pages).

The above identified foreign applications and the above identified article were cited in an office action during the prosecution of a related German application. The above identified U.S. applications are English language equivalents to the above identified foreign applications as explained below.

U.S. Patent Application Publication No. US 2002/0179942 A1 claims priority to DE 100 52 170.3.

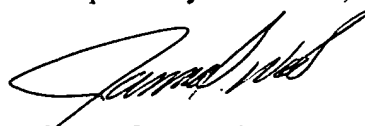
U.S. Patent Application Publication No. US 2002/0167082 A1 claims priority to DE 101 22 364.1.

U.S. Patent Application Publication No. U.S. 2003/0057479 A1 claims priority to DE 100 12 610.3.

It is believed that no fees are due for the consideration of this Information Disclosure Statement. However, the Commissioner is hereby authorized to charge any deficiency or to credit any overpayment to Deposit Account No. 13-0014, but not to include any payment of issue fees.

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INFORMATION DISCLOSURE STATEMENT

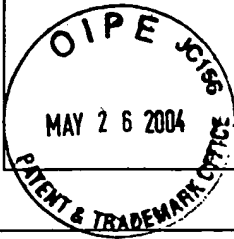
MMB DOCKET NO. 1890-0064

APPLICATION NO.: 10/798,720

APPLICANT(S): Krumbein et al.

FILING DATE: March 11, 2004

GROUP ART UNIT: To be assigned



## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA	2002/0179942 A1	December 5, 2002	Tihanyi			
	AB	2002/0167082 A1	November 14, 2002	Weber et al.			
	AC	2003/0057479 A1	March 27, 2003	Ahlers et al.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION
	AL	DE 100 52 170 C2	October 31, 2002	DE			Yes No
	AM	DE 101 22 364 A1	November 21, 2002	DE			Yes No
	AN	DE 100 12 610 A1	September 27, 2001	DE			Yes No
	AO						Yes No
	AP						Yes No

## OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AQ	1	Appels, J.A., H.M.J. Vaes, "High Voltage Thin Layer devices (Resurf Devices)", Philips Research Laboratories Eindhoven - Netherlands, IEEE, © 1979, pages 238 - 241, (4 pages).
	AR	1	
	AS	1	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicants.